

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Cho, et al

Docket No.:

Examiner:

24061.30

Serial No.:

10/706,565

99999999

To Be Determined

Filed:

November 11, 2003

2812

Entitled:

RF Antenna Design for Improved

Film Uniformity of an Ion Metal

Plasma Source

Art Unit:

## INFORMATION DISCLOSURE STATEMENT

Commissioner For Patents P.O. Box 1450 Alexandria, VA 22313-1450

In compliance with the duty of disclosure under 37 CFR §1.56, and in accordance with the practice under 37 CFR §1.97 and §1.98, the Examiner's attention is directed to the documents listed on the enclosed modified Form PTO-1449. No inference should be made that the cited references are in fact material, are in fact prior art, or that no better art exists. The cited patents are listed in numerical order and are not in any order based on their pertinence.

The above-identified application was filed after June 30, 2003. Therefore, pursuant to the waiver of the requirement under 37 CFR 1.98 (a)(2)(i) as stated in a Pre-OG Notice dated July 11, 2003, copies of the U.S. patents listed on the enclosed modified Form PTO-1449 are not being provided.

This Information Disclosure Statement is being filed within three months of the United States filing date or before the mailing date of a first Office Action on the merits. No certification or fee is required (37 CFR §1.97(b)).

The Commissioner is hereby authorized to charge any additional fees which may be required or credit any overpayment to Deposit Account 08-1394.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Date: 3-4-

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner For Patents, Washington, D.C. 20231 on the date indicated below. Alexandria, VA

22313

Name

Date

In place of O PS DEPARTMENT OF COMMERCE PTO-1449 PATENT AND TRADEMARK OFFICE Form				Complete if Known		
/	R I 9 AMON C	NSCL O	SURF	Application Number Filing Date	10/706,565 November 11, 2003	
STATEMENT BY APPLICANT  Suse as man series as necessary)				Applicant(s)	Cho et al.	
				Art Unit	2812	
				Examiner Name	To Be Determined	
SHEET	1	OF	1	Attorney Docket Number	24061.30	

U. S. PATENT DOCUMENTS				
Examiner's	Cite / No.	- Document Number	Publication Date	Name of Patentee or Applicant of Cited Document
	AA	6,498,091	12-24-2002	Chen et al.
	AB	6,512,281	01-28-2003	Ito
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	AD	US 2001/0003607 A1	06-14-2001	Gopalraja et al.
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	AH	US 2002/0125123 A1	09-12-2002	Ngan et al.
	Al	US 2002/0182887 A1	12-05-2002	Pavate et al.
	AJ	US 2002/0189932 A1	12-19-2002	Bhowmik et al.
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Examiner's Initials	Cite ( No.	Foreign Patent  Document  Country Code - Number - Kind)	Publication Date	Patentee or Applicant of Cited Document	Translation
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	OTHER PRIOR ART					
Examiner's		Include name of the author (in CAPITAL LETTERS), title of the article, title of the item, date, page(s), issue number(s), publisher, city/country where published				
Examiner Signature			Date Considered			

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.

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